



AF 2815
\$ JFW
Attorney Docket No. 0756-2256

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koichiro TANAKA

Serial No. 09/774,637

Filed: February 1, 2001

For: BEAM HOMOGENIZER, LASER
IRRADIATION APPARATUS,
SEMICONDUCTOR DEVICE, AND
METHOD OF FABRICATING THE
SEMICONDUCTOR DEVICE

) Group Art Unit: 2815

) Examiner: J. Diaz

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) Adeline M. Stamps

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated January 9, 2004, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.